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				Application Number	10/686982
				Filing Date	10/16/03
				First Named Inventor	Baumann et al.
				Group Art Unit	2874
Examiner Name	Rah11				
Sheet	1	of	1	Attorney Docket No.	MAIKP104US

U.S. PATENT DOCUMENTS						
Exam. Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Doc.	Date of Pub. of Cited Doc. (mm-dd-yyyy)	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
JR	AA	5.367.584		Ghezze et al.	11/22/1994	Entire Document
	AB					
	AC					
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FOREIGN PATENT DOCUMENTS								
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		Office ³	Number ⁴	Kind Code ² (if known)				
JR	BA	EP	1 085 354	A2	Masayuki et al.	03/21/2001	Entire Document	
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OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Exam. Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
JR	CA	"GaAs-based microelectromechanical waveguide switch", OLGA BLUM SPAHN, CHARLES SULLIVAN, JEFF BURKHART, CHRIS TIGGES and ERNIE GARCIA, IEEE/LEOS International Conference on Optical MEMS, Sheraton Kauai, Resort Kauai, Hawaii, August 21024, 2000, 3 pgs.	
	CB		
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Examiner Signature	<i>[Signature]</i>	Date Considered	6/15/05
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